(11) EP 1 093 017 A3

(12)

### **EUROPEAN PATENT APPLICATION**

(88) Date of publication A3: 04.08.2004 Bulletin 2004/32

(51) Int Cl.7: **G03F 7/20**, G03F 1/00

(43) Date of publication A2: 18.04.2001 Bulletin 2001/16

(21) Application number: 00122146.4

(22) Date of filing: 12.10.2000

(84) Designated Contracting States:

AT BE CH CY DE DK ES FI FR GB GR IE IT LI LU MC NL PT SE

Designated Extension States: AL LT LV MK RO SI

(30) Priority: 13.10.1999 US 417518

(71) Applicant: Applied Materials, Inc.
Santa Clara, California 95052 (US)

(72) Inventors:

 Kenan, Boaz Rehovot (IL)

- Eran, Yair Rehovot (IL)
- Karpol, Avner Nes Ziona (IL)
- Elyasaf, Emanuel Rehovot (IL)
- Tirosh, Ehud Jerusalem (IL)
- (74) Representative: Zimmermann, Gerd Heinrich et al
   Zimmermann & Partner,
   P.O. Box 33 09 20
   80069 München (DE)

#### (54) Method and apparatus for reticle inspection using aerial imaging

(57)A reticle inspection system for inspecting reticles can be used as an incoming inspection tool, and as a periodic and pre-exposure inspection tool. Mask shops can use it as an inspection tool compatible to their customers, and as a printable error detection tool. The inventive system detects two kinds of defects: (1) line width errors in the printed image; (2) surface defects. The line width errors are detected on the die area. The detection is performed by acquiring the image of the reticle under the same optical conditions as the exposure conditions, (i.e. wavelength, numerical aperture, sigma, and illumination aperture type) and by comparing multiple dies to find errors in the line width. Surface defects are detected all over the reticle. The detection of surface defects is performed by acquiring transmission and dark-field reflection images of the reticle and using the combined information to detect particles, and other surface defects.

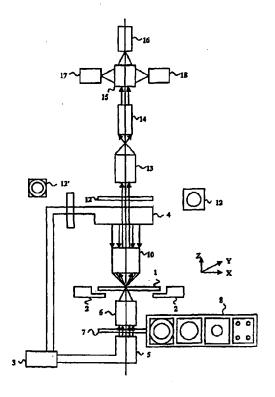


FIG. 1



# **EUROPEAN SEARCH REPORT**

Application Number EP 00 12 2146

| Category                  | Citation of document with it of relevant pass   | ndication, where appropriate, sages  | Relevant<br>to claim  | CLASSIFICATION OF THE APPLICATION (Int.CI.7) |
|---------------------------|---|--|---|--|
| Y                         | US 4 247 203 A (SAN 27 January 1981 (19   | DLAND PAUL ET AL)  | 1-4,6-8,<br>11,13,<br>14,<br>25-36,<br>38,40,<br>41,<br>43-47,<br>50-52,<br>55,56 | G03F7/20<br>G03F1/00                         |
|                           | * figure 2 *<br>* column 7, line 44   | -51 *  |   |  |
| D,X                       | EP 0 628 806 A (IBM<br>14 December 1994 (1  |  | 24,39   |  |
| Y                         | * abstract; figure  |  | 1-4,6-8,<br>11,13,<br>14,<br>25-31,<br>37,40,                                     |  |
| :                         |   |  | 41,<br>45-47,<br>50-52,<br>55,56  | TECHNICAL FIELDS<br>SEARCHED (Int.Cl.7)      |
|                           | * column 7, line 50<br>* column 8, line 13  | 8 * -29 * -16 * -43 * - column 6, line 5 * - column 8, line 3 * -18 * - column 9, line 3 * -47 * | *   |  |
|                           |   | -/   |   |  |
|                           | The present search report has   | been drawn up for all claims   |   |  |
| ·                         | Place of search   | Date of completion of the sear   |   | Exeminer                                     |
|                           | THE HAGUE   | 17 May 2004  | Men   | ck, A  |
| X : par<br>Y : par<br>doc | ATEGORY OF CITED DOCUMENTS<br>ticularly relevant if taken alone<br>ticularly relevant if combined with ano<br>ument of the same category<br>hnological background | E : earlier pate<br>after the fill<br>ther D : document<br>L : document o                        | cited in the application<br>cited for other reasons                               | ished on, or                                 |

2



## **EUROPEAN SEARCH REPORT**

Application Number EP 00 12 2146

|  |   | RED TO BE RELEVANT   | Delayant                                    | ALABORIOA TON OF THE                         |  |
|--|---|--|---|--|--|
| Category                               | Citation of document with in<br>of relevant passa   |  | Relevant<br>to claim                        | CLASSIFICATION OF THE APPLICATION (Int.CI.7) |  |
| X                                      | mask evaluation, the<br>Aerial Image Measure<br>IBM JOURNAL OF RESE<br>JANMARCH 1997, IBI<br>vol. 41, no. 1-2,<br>XP002279986   | v tool for lithographic<br>s stepper equivalent<br>ement System, AIMS"<br>ARCH AND DEVELOPMENT,<br>M, USA,   | 53,54                                       |  |  |
| Y                                      | ISSN: 0018-8646<br>* figures 2,6,7,10   |  | 32-36,<br>38,43,44                          |  |  |
|  | *<br>* page 123, right-h  | and column, line 23-26 and column, line 26-31  |   |  |  |
|  | *<br>* page 125, right-h<br>* abstract *  | and column *   |   |  |  |
| <b>Y</b>                               |   | N OF NEW SUPER<br>E"<br>CIENCE AND TECHNOLOGY:<br>STITUTE OF PHYSICS. NEW<br>96-11-01), pages<br>146   | 37  | TECHNICAL FIELDS<br>SEARCHED (Int.Cl.7)      |  |
|  | The present search report has   | been drawn up for all claims   |   |  |  |
|  | Place of search   | Date of completion of the search   | <del>-1</del>                               | Examiner                                     |  |
|  | THE HAGUE   | 17 May 2004  | Men   | ick, A                                       |  |
| X:par<br>Y:par<br>dox<br>A:teo<br>O:no | CATEGORY OF CITED DOCUMENTS<br>ticularly relevant if taken alone<br>ticularly relevant if combined with anol<br>turnent of the same category<br>hnological background<br>n-written disclosure<br>armediate document | E : earlier patent of after the filing there is a comment cited to the cited to th | d in the application<br>I for other reasons | ished on, or                                 |  |

### ANNEX TO THE EUROPEAN SEARCH REPORT ON EUROPEAN PATENT APPLICATION NO.

EP 00 12 2146

This annex lists the patent family members relating to the patent documents cited in the above-mentioned European search report. The members are as contained in the European Patent Office EDP file on The European Patent Office is in no way liable for these particulars which are merely given for the purpose of information.

17-05-2004

|    | Patent document<br>cited in search repo | ort | Publication date |                      | Patent fam<br>member(s                    | tily<br>s) | Publication date                                     |
|----|---|-----|------------------|----------------------|---|------------|--|
| US | 4247203                                 | Α . | 27-01-1981       | JP<br>JP<br>US<br>WO | 1050844<br>55500510<br>4347001<br>7900876 | T<br>A     | 31-10-1989<br>14-08-1980<br>31-08-1982<br>01-11-1979 |
| EP | 0628806                                 | A   | 14-12-1994       | EP<br>JP             | 0628806<br>7028226                        | A2<br>A    | 14-12-1994<br>31-01-1995                             |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     | ·                |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |
|    |   |     |                  |                      |   |            |  |

For more details about this annex : see Official Journal of the European Patent Office, No. 12/82